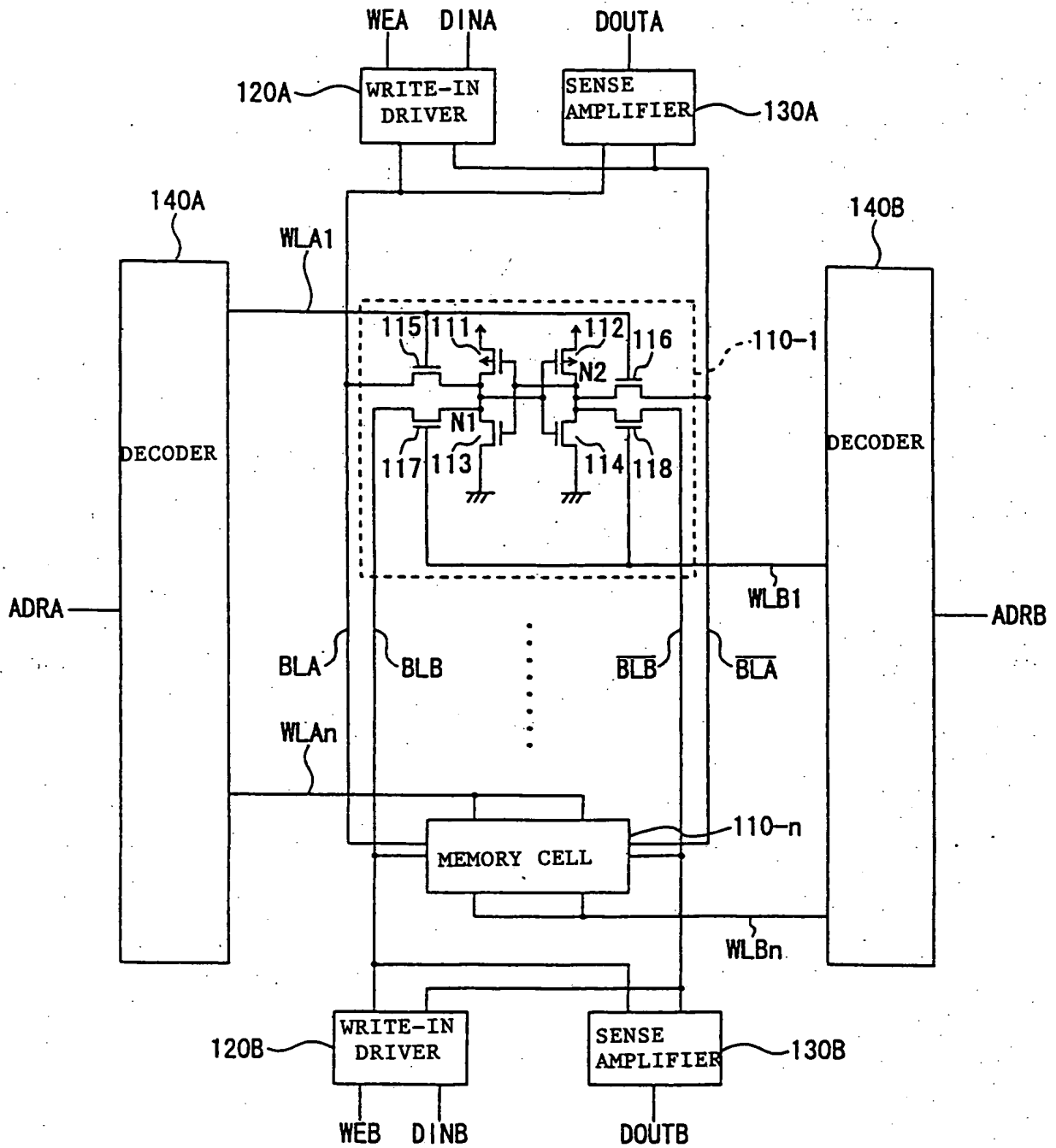


FIG. 3

300



REPLACEMENT DRAWING



STRUCTURE OF MULTI-PORT SEMICONDUCTOR
MEMORY FOR COMPARISON

PRIOR ART